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	Application No.	Applicant(s)	
Notice of Allowability	10/756,759	CHEN ET AL.	
	Examiner	Art Unit	
	Thao P. Le	2818	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to 6/18/04.			
2. ☑ The allowed claim(s) is/are <u>1-34</u> .			
3. $\boxtimes$ The drawings filed on <u>14 January 2004</u> are accepted by the	e Examiner.		
<ul> <li>4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). <ul> <li>a)</li></ul></li></ul>			
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**DETAILED ACTION** 

Claims 1-34 are pending.

Reason for allowance

Claims 1-34 are allowed. The following is an examiner's statement of reason for

allowance: None of the references of record teaches or suggests the claimed limitations

having a method of trimming a gate electrode structure and a processing tool for trimming

the gate electrode comprising, among other steps, providing a gate electrode, selecting a

trimming recipe, forming a reaction layer with the gate electrode and etching the reacted

portions to obtain a smaller dimension gate electrode.

Any comments considered necessary by applicant must be submitted no later than

the payment of the issue fee and, to avoid processing delays, should preferably

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance".

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## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao P. Le whose telephone number is 571-272-1785. The examiner can normally be reached on M-T (7-6).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on 571-272-1787. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thao P. Le Examiner Art Unit 2818 Sept. 29, 2004 Supervisory Patent Examiner Technology Center 2800